## APPLICATION DATA SHEET

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Attorney Docket Number: BUR92000077

Publication Filing Type:

new-utility

**Application Type:** 

utility

Title of Invention:

SINGLE REACTOR, MULTI-PRESSURE CHEMICAL VAPOR

**DEPOSITION FOR SEMICONDUCTOR DEVICES** 

Attorney Docket Number:

BUR920000077

Legal Representative:

Attorney or Agent:

Mr. Robert A. Walsh Esq.

Registration Number:

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Customer Number Correspondence Address:

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Jack

Middle Name:

Ο.

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